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BIBDATASHEET

CONFIRMATION NO. 9751

Bib Data Sheet

SERIAL NUMBER 10/670,855	FILING DATE 09/25/2003 RULE	CLASS 451	GROUP ART UNIT 3723	ATTORNEY DOCKET NO. SAM-0225DIV
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** CONTINUING DATA ***** AD

This application is a DIV of 09/877,922 06/07/2001 PAT 6,652,362

** FOREIGN APPLICATIONS ***** AD

REPUBLIC OF KOREA 00-69983 11/23/2000

REPUBLIC OF KOREA 01-11055 03/03/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/18/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: <u>AD</u> Initials: _____	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 18	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 4
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TITLE

Apparatus for polishing a semiconductor wafer and method therefor

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
RECEIVED	No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> 1.16 Fees (Filing)
	No. _____ for following:	<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)